

	L #	Hits	Search Text
1	L1	103235	(mask or reticle) and (wafer or substrate)
2	L2	55520	(detect\$4 or monitor\$3 or obtain\$4) same (move or moving moved or movement or vibration or shift\$4) same (projection or optical)
3	L3	5199	1 and 2
4	L4	83268	(hold\$3 or frame or support\$3 or tray) near5 (projection or optical)
5	L5	1053	4 with actuator
6	L6	40	3 and 5
7	L7	17	6 and (355/\$.ccls. or 356/399-401.ccls. or 318/687.ccls. or 248/550.ccls. or 248/638.ccls.)

R/C

11/21/82